

FORM PTO-14
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PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
93-C-077C1 (STMI01-93077)SERIAL NO.
09/712,827LIST OF REFERENCES CITED BY APPLICANT
(Use several sheets if necessary)APPLICANT
Loi N. Nguyen, et al.FILING DATE
November 14, 2000GROUP
~~2835~~

U. S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (if appropriate)
LP	AA	4,686,000	08/11/1987	Heath	156	643	Feb. 19, 1986
	AB	4,824,767	04/25/1989	Chambers, et al.	430	313	Jun. 2, 1987
	AC	5,063,176	11/05/1991	Lee, et al.	437	195	May 30, 1990
	AD	5,166,088	11/24/1992	Ueda, et al.	437	47	Jun. 25, 1991
	AE	5,266,516	11/30/1993	Ho	437	57	Jan. 2, 1992
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
LP	AH	0 523 856 A2	06/28/91	Europe				
LP	AI	0 534 130 A1	3/31/93	Europe				
LP	AJ	JP60246675	06/12/85	Japan				
LP	AK	JP4196486	07/16/92	Japan				
LP	AL	JP5074958	03/26/93	Japan				
	AM							

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

LP	AN	"VLSI Fabrication Principles," by Sorab K. Ghandhi, Rensselaer Polytechnic Institute, A Wiley-Interscience Publication, John Wiley & Sons, 1983, pages 479-482, 499-501.
	AO	
	AP	

EXAMINER

Long Pham

DATE CONSIDERED

2/7/02.

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line if not in conformance and not considered. Include copy of this form with next communication to applicant.